

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	(substrate same variation same etch same rate and ion near implantation). clm.	US-PGPUB; USPAT	OR	OFF	2006/06/14 08:20
L2	1	(substrate same variations same etch same rate and ion near implantation). clm.	US-PGPUB; USPAT	OR	OFF	2006/06/14 08:20